

Form PTO-1449 (modified)		Atty. Docket No.: ESSR:090US	Serial No.: 10/523,951
List of Patents and Publications for Applicant's  INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)		Applicant: Karin SCHERER <i>et al.</i>	
		Filing Date: February 8, 2005	Group: 1794
U.S. Patent Documents <i>See Page 1</i>	Foreign Patent Documents <i>See Page 1</i>	Other Art <i>See Page 1</i>	

### U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.

### Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Language

### Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
/JL/	C2	Decker <i>et al.</i> , "Thin Film Magnetic Structure with Diffusion Barrier Layer," <i>IBM Technical Bulletin</i> , 22:2865, 1979.

60064944.1

EXAMINER: /Jonathan Langman/

DATE CONSIDERED: 01/07/2008

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

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